

**Search Notes**

Application/Control No.

10/671,349

Examiner

Arnel C. Lavarias

Applicant(s)/Patent under  
Reexamination

KIRCHHUEBEL, RAINER

Art Unit

2872

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
Interference search (See attached)		5/13/2006	ACL

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
359/368,381,382,383,384,811,813,819,822,823,824,827,830 Limited class search (See attached)	5/13/2006	ACL
351/205,216,245 Limited class search (See attached)	5/13/2006	ACL
EAST text search (See attached)	5/13/2006	ACL